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Bib Data Sheet

CONFIRMATION NO. 1294

SERIAL NUMBER 09/945,247	FILING DATE 08/31/2001 RULE	CLASS 257	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. 9319T-000281
APPLICANTS Seiichiro Higashi, Chino-city, JAPAN; Daisuke Abe, Suwa-city, JAPAN;				
** CONTINUING DATA ***** <i>None ins</i>				
** FOREIGN APPLICATIONS ***** JAPAN 2000-267286 09/04/2000 JAPAN 2001-263559 08/31/2001 <i>Yes ins</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/04/2001				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance Verified and Acknowledged <i>Attorney's Signature</i> <i>ins</i> Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 4
ADDRESS 27572				
TITLE Method for fabrication of field-effect transistor <i>to Reduce Defects At MOS Interfaces Formed at Low Temperature</i>				
FILING FEE RECEIVED 954	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	